

Notice of References Cited	Application/Control No. 10/691,055	Applicant(s)/Patent Under Reexamination KRYLIOUK ET AL.	
	Examiner Sara W. Crane	Art Unit 2811	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,579,609	04-1986	Reif et al.	117/97
	B	US-6,069,021	05-2000	Terashima et al.	438/46
	C	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kumashiro, Y. et al., "Epitaxial growth of rhombohedral boron phosphide singel crystalline films by chemical vapor deposition," Journal of Solid State Chemistry, 133, 104-112 (1997), pp 104-112.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.